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JEWIA
12-16-03

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q56532

Hideya TAKEO

Appln. No.: 09/489,846

Group Art Unit: 2621

Confirmation No.: 6337

Examiner: Ryan J. Miller

Filed: January 24, 2000

For: ABNORMAL PATTERN DETECTION PROCESSING METHOD AND SYSTEM

AMENDMENT UNDER 37 C.F.R. § 1.111

RECEIVED

MAIL STOP NON-FEE AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

DEC 09 2003

Technology Center 2600

Sir:

In response to the Office Action dated September 10, 2003, please amend the above-identified application as follows on the accompanying pages.

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